## Application/Control No. Applicant(s)/Patent Under Reexamination 10/613,762 LEDER ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 Cybille Delacroix-Muirheid 1614 **U.S. PATENT DOCUMENTS** Document Number Date Name Classification Country Code-Number-Kind Code MM-YYYY \* US-2005/0086748 04-2005 Rondeau et al. 008/406 Α US-В US-С US-D US-Ε US-F US-G US-Н US-1 US-J US-K US-L US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Classification Country Code-Number-Kind Code Country Name MM-YYYY N 0 Ρ Q R S 1 **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U ٧ Х 3-20-06

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